

# SIEMENS

PATENT  
Attorney Docket No. 2003P08356WOUS

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Inventor:	S. Haaks et al.	)	Group Art Unit:	2125
		)		
Serial No.:	10/559,865	)	Confirm. No.:	7446
		)		
Filed:	12/07/2005	)	Examiner:	LAUGHLIN, Nathan L.
Title:	METHOD AND DEVICE FOR DETERMINING THE CAUSES OF FAILURES IN INDUSTRIAL PROCESSES			

Mail Stop AF  
**Commissioner for Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

### RESPONSE AFTER FINAL REJECTION UNDER 37 CFR 1.116

In response to the final rejection contained in the Office Communication mailed October 9, 2007, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application. Entry of this amendment is respectfully requested in order to place the application in condition for allowance, or in the alternative, to place the application in better form for consideration upon appeal.

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